



**ELECTRONIC COPY**

LG754564646  
Report verification at igi.org



December 16, 2025

IGI Report Number **LG754564646**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **7.93 - 7.96 X 4.85 MM**

**GRADING RESULTS**

Carat Weight **1.90 CARAT**

Color Grade **F**

Clarity Grade **VVS 2**

Cut Grade **IDEAL**

December 16, 2025  
IGI Report Number **LG754564646**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **ROUND BRILLIANT**  
Measurements **7.93 - 7.96 X 4.85 MM**

**GRADING RESULTS**

Carat Weight **1.90 CARAT**

Color Grade **F**

Clarity Grade **VVS 2**

Cut Grade **IDEAL**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

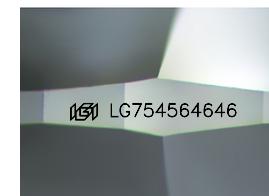
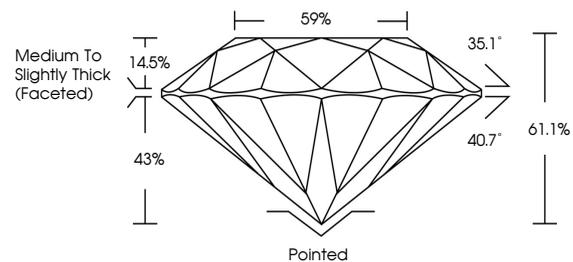
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG754564646**

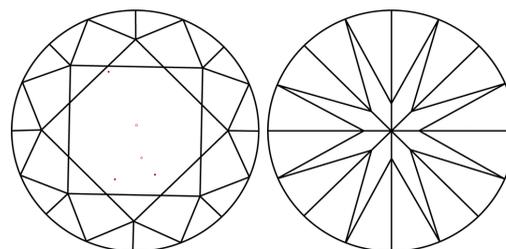
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

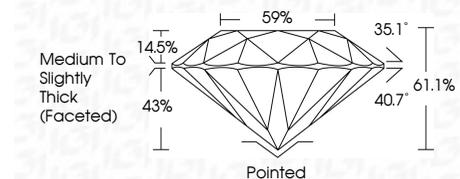
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG754564646**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa



December 16, 2025	IGI Report No LG754564646	ROUND BRILLIANT	7.93 - 7.96 X 4.85 MM	1.90 CARAT	F	VVS 2	IDEAL	61.1%	59%	Medium To Slightly Thick (Faceted)	Pointed	EXCELLENT	EXCELLENT	NONE	IGI LG754564646
				Carat Weight	Color Grade	Clarity Grade	Cut Grade	Depth	Table	Grade	Culet	Polish	Symmetry	Fluorescence	Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa